



Attorney Docket No. 7553.0008

In re Application of:

Chishio KOSHIMIZU et al.

) Group Art Unit: 1765 ✓

Application No: 09/665,940

) Examiner: L. UMEZ ERONINI

Filed: September 21, 2000

For: PLASMA PROCESSING  
APPARATUS AND PLASMA  
PROCESSING METHOD

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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Sir:

## PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a one month extension of time to reply to the Office

Action of August 27, 2003. A fee of \$110.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

By:

Michael W. Kim  
Reg. No. 51,880

Dated: December 4, 2003

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